Discussion about next HPK productions for EIC

Koji, Artur, Zhenyu

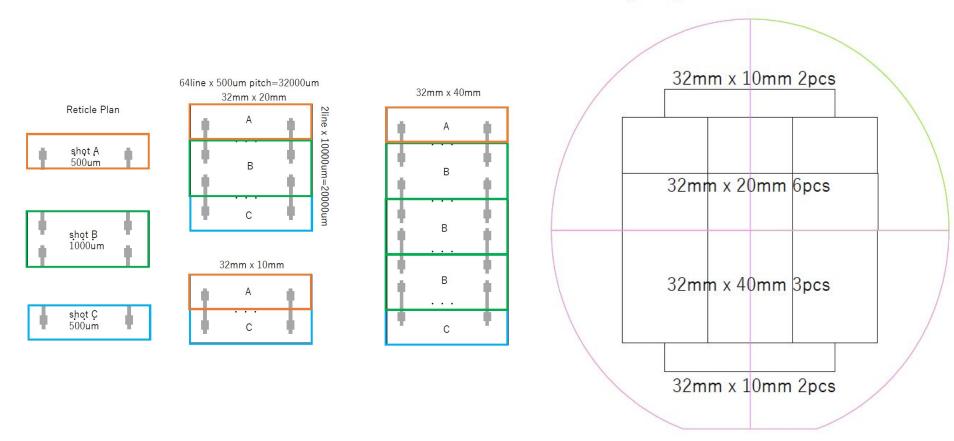
11/14/2023

Next HPK Production (update on 11/14)

- Improve timing and spatial resolutions
 - 1-cm long, 50-um thick, E-type strip: need to improve timing resolution from ~35 to <30 ps
 - Suffer from small amplitude, increasing sensor thickness and/or reducing charge sharing (higher resistivity or lower interstrip capacitance, or wider metal width) can help?
 - Smaller electrodes to reduce interstrip capacitance,
 - -> reduce metal width from 50 um to 40 um? (possible down to 10 um but increased resistivity)
 - -> shorten the electrodes and increase pitch?
 - -> reduce the thickness from 50 um to 35/40 um? Ask HPK
 - 150-um metal, 20-um thick, pad: improve spatial resolution under metal from ~50 to 20 um
 - Reduce metal electrode width from 150 to 100-75-50 um -> Doable
 - 20/50->20/30 um thick? -> Doable
- Produce large sensors for module assembly
 - Strip baseline: 64*4 strips with 500-um pitch and 1-cm length, with active area 3.2x4 cm²
 - One wafer can include four $3.2x1 + six 3.2x2 + three 3.2x4 cm^2$
 - Pad baseline: 32*32 pads with 500-um pitch, with active area 1.6*1.6 cm²
 - One wafer can include twenty 1.6x1.6 cm², two types
 - Previous production 2x2 cm2 yield was low. No guarantee in good yield for test production
 - Purchase good dies instead of number of wafers

Proposal to Stitch Strip Sensors by HPK (11/14)

Wafer layout plan



Discussion about next HPK productions for EIC

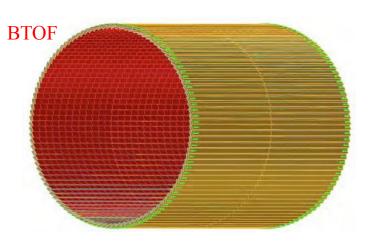
Koji, Artur, Zhenyu

11/1/2023

Early Summary

- By CD2/3 review (10/2024), the EIC detector design should be 90% final (70-80% is not ideal but acceptable).
- Encouraging results from the sensors from the first HPK production.
- Next HPK production(s), ideally tested in Spring 2024 focus on
 - Improve timing resolution for strip sensor, and spatial resolution under the metal for pad sensors
 - Produce large sensors in preparation for CD2/3 (module prototyping, cost/yield estimates)
- Question: schedule/cost of such productions, cost for construction

AC-LGAD Detectors for ePIC



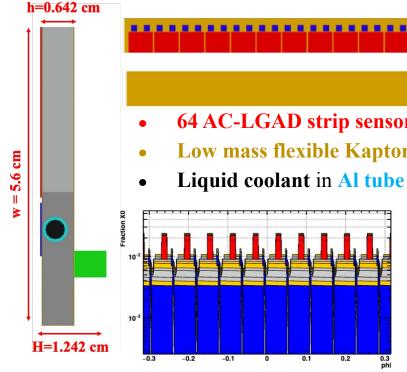




	Area (m²)	Channel size (mm²)	# of Channels	Timing Resolution	Spatial resolution	Material budget
Barrel TOF	10	0.5*10	2.4M	35 ps	30um	0.01 X ₀
Forward TOF	1.4	0.5*0.5	5.6M	25 ps	30um	$0.025 X_0$
B0 tracker	0.07	0.5*0.5	0.28M	30 ps	20 um	$0.05 X_0$
RPs/OMD	0.14/0.08	0.5*0.5	0.56M/0.32M	30 ps	30um	no strict req.
the design matures, and we will continue to explore common designs for these detectors where possible to reduce cost and						

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ePIC BTOF Detector Module Conceptual Design



- **64 AC-LGAD strip sensors**, each 3.2*4 cm² read out by **2 ASICs**
- Low mass flexible Kapton PCB distributes power and I/O signals from connector
- Liquid coolant in Al tube embedded in CF light-weight structure for heat removal

144 modules, each with 2 readout boards with 2 LV+HV cables, 2 DAQ fiber, and 1 cooling line

Power consumption: ~4 kW (2.4kW for ASIC, 1 kW for DC-DC, 0.6kW for sensors+cable)

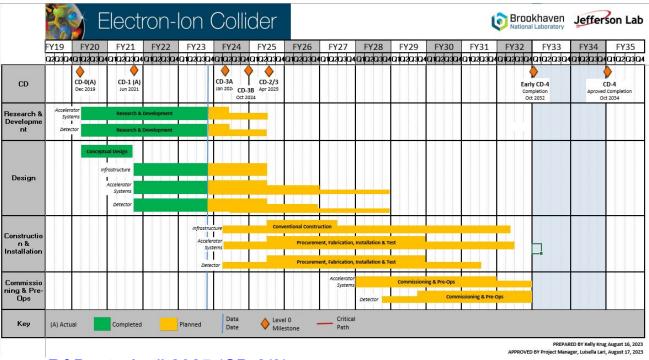
Total weight: ~70 kG

STAR IST

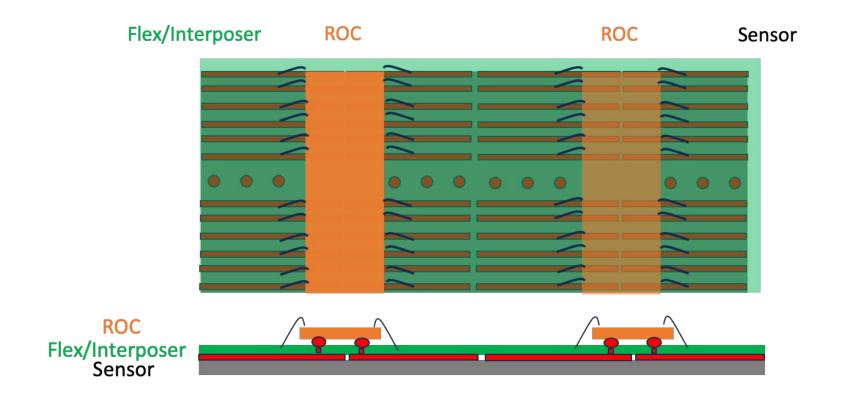




EIC Project Schedule



- R&D to April 2025 (CD-2/3)
- Design to October 2028
- Construction & Installation to April 2031
- Commissioning & Pre-Ops to October 2032

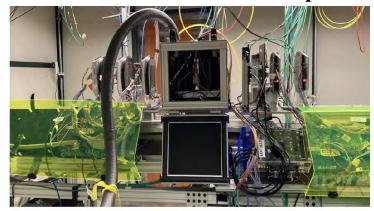


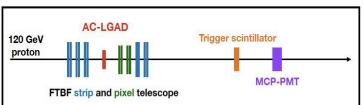
AC-LGAD Sensor R&D

Sensor

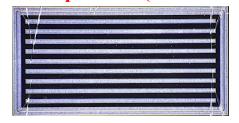
- Sensors with different configurations produced by BNL-IO and Hamamatsu, and tested with 120GeV protons
- Prototype strip sensors with ~34 ps time resolution and 12-15 um spatial resolution for BToF.
- Prototype pixel sensors with ~ 20 ps time resolution and ~ 20 * um spatial resolution for FToF, B0, RPs/OMD. * ~50 um under the metal eletrode. To be improved

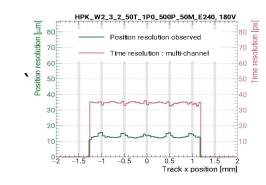
Fermilab Test Beam Setup

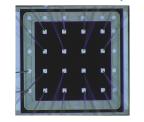


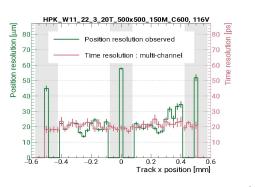


HPK Strip Sensor (4.5x10 mm²) HPK Pixel Sensor (2x2 mm²)









Zhenyu Ye @ LBNL/UIC

Two? HPK Productions

- Improve timing and spatial resolutions
 - 1-cm long, 50-um thick, E-type strip: need to improve timing resolution from ~35 to <30 ps
 - Suffer from small amplitude, increasing sensor thickness and/or reducing charge sharing (higher resistivity or lower interstrip capacitance, or wider metal width) can help?
 - E-type is the highest resistivity HPK, 50 um dominated by Landau so not thicker
 - Smaller electrodes to reduce interstrip capacitance
 - -> reduce metal width from 50um? Shorten the electrodes and increase pitch?
 - 150-um metal, 20-um thick, pad: improve spatial resolution under metal from ~50 to 20 um
 - Reduce metal electrode width from 150 to 100-75-50 um -> Doable
 - 20->30 um thick? -> Doable
- Produce large sensors for module assembly
 - Strip baseline: 64*4 strips with 500-um pitch and 1-cm length, with active area 3.2x4 cm²
 - Start from 1.6x2, **3.2x2?**, or 3.2x4 cm²
 - Pad baseline: 32*32 pads with 500-um pitch, with active area 1.6*1.6 cm²
 - Start from **1.6x1.6?**, 1.6x3.2, or 3.2x3.2 cm²
 - Previous production 2x2 cm² yield was low, cracks in wafer materials, will try to avoid but not guaranteed. **Ask HPK**

Summary

- By CD2/3 review (10/2024), the EIC detector design should be 90% final (70-80% is not ideal but acceptable).
- Encouraging results from the sensors from the first HPK production.
- Next HPK production(s), ideally tested in Spring 2024 focus on
 - Improve timing resolution for strip sensor, and spatial resolution under the metal for pad sensors
 - Produce large sensors in preparation for CD2/3 (module prototyping, cost/yield estimates)
- Question:
 - schedule/cost of such R&D productions
 - cost for construction (HPK-US)